I hereby certify this correst by dence is being deposited with the U.S. Postal Service with sufficient factors of Service with sufficient factors of Service with sufficient factors of Patents, P.O. Box 1450, Alexandria, VA 2313-1450, and the date of Service between the service between 22313-1450, on the date shown below. Dated: September 28, 2004 Signature:

Docket No.: 30205/39412

(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: Young Sun Hwang et al.

Application No.: 10/603,012

Art Unit: 1756

Examiner: Daborah Chacko Davis Filed: June 24, 2003

For: PHOTORESIST OVERCOATING

COMPOSITION

AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the non-final office action mailed on July 1, 2004, please amend the above-identified patent application as follows.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks in support of the allowability of this application begin on page 4 of this paper.